IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Steven J. Koester

Examiner: Anh D. Mai

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Commissioner of Patents and Trademarks

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/ease /b 207 1 6/21/200 In response to the Office Action dated March 13, 2007, constituting a Final Rejection, applicants respectfully request the Examiner to reconsider the application in view of the following amendments and remarks.

> Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

> > Remarks begin on page 7 of this paper.

CERTIFICATE OF ELECTRONIC FILING

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